Simulation and instrumentation for the future Electron-Ion Collider

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Exclusive process in future EIC

The first data taking

will be in 2030

- The Generalized Parton Distribution (GPD) framework is a recent approach to understand the nucleon structure in further detail. It can also be used to study the spin structure of the proton.
- Deep Virtual Compton Scattering (DVCS) is a exclusive process that can provide access to the GPDs of the proton e⁻ + p -> e⁻ + γ + p
- A new electron ring will be added to Relativistic Heavy Ion Collider (RHIC) and the requirements:
 - highly polarized e- beam(~70%) and proton beam(~70%)
 - ion beam from deuteron to gold, lead or uranium
 - high luminosity: 10³³~10³⁴ cm⁻²s⁻¹
 - e⁻+proton center of mass energy up to 140 GeV



AGS

Exclusive process in future EIC

• In the DVCS process, $e^2 + p \rightarrow e^2 + \gamma + p$

- most scattered e- and photons go to the lepton Endcap and some toward the barrel detector.

- The recoil protons go to the far-forward region and will be detected by the Roman Pots



Outline

- Backward endcap EM calorimeter and Roman pot play an important role in DVCS process measurement e⁻ + p -> e⁻ + y + p
- Our Work on backward endcap EM calorimeter:
 - crystal property measurements
 - construct the EEMC configuration in simulation
- Our work on Roman pot:
 - silicon sensor characteristic measurements
 - simulation study regarding the position resolution

Calorimeter - crystal radiation hardness

- Goal: determine crystals radiation hardness (30gy/year in end cap Calorimeter)
- Crystal: lead tungsten, manufacturer: Crytur
- Requirement: <20% transmittance loss after 30 Gy of radiation dose

Crystal property	
Parameter	PbWO4
Density	8.28 g/cm ³
Radiation length	0.9 cm
Emission peak[nm]	420 nm
Light yield	15 p.e. / MeV
Decay constant	25 ns



Crystal in the spectrometer









Calorimeter - crystal light yield

- Goal: use a Photo Multiplier Tube (PMT) to determine the crystal light yield.
- The crystal is wrapped with high reflective film
- The averaged light yield of 10 crystals:
 30 photo-electrons (p.e.)







The light yield of 10 crystals with different radiation sources

Calorimeter resolution study

- The backward End cap EM Calorimeter (EEMC) is placed at -1.75m from the interaction point and is composed of ~2000 crystals
- The position and energy resolution of the EEMC is related to its geometry, material, noise....
- The position resolution of the EEMC is ~10% of The blue one is crystal size End cap Calorimeter in simulation The energy resolution of the EEMC is good and . consistent with the physics requirements Crystal posx rescotrustion Crystal posy rescotrustion 450_r юш7 500 400 $-\frac{\sigma}{E} = 1.39 \oplus \frac{2.52}{\sqrt{E}}$ 350 Posx resolution: 0.275 cm 400 Posx resolution: 0.212 cr 300 $\frac{\sigma}{E} = 1.52 \oplus \frac{2.24}{\sqrt{E}} \oplus \frac{0.77}{E}$ 250 300 200 200 150 $\sigma x = 0.25 cm$ $\sigma y = 0.25 cm$ 100 100 50 F 0 -2 2 -2 2 0 0 projection - reconstruction[cm] 5 10 15 30 projection - reconstruction[cm]

E [GeV]

Roman Pots

- AC couple-Low Gain Avalanche Diodes (AC-LGAD) are silicon sensors with:
 - good timing resolution
 - good position resolution (pixel size: 0.5x0.5 & 1.3x1.3 mm²)
- Using the well developed ASIC, ALTIROC (2 TDC), as the readout to study the performance of AC-LGAD, sharing and the resolution





Simulation of signal sharing among neighboring pixels

- Different inject position, noise level and inject energy are simulated
- Implement the ADC algorithm
- Position resolution for different ADC resolution and resistor value
- We can reconstruct the injected position within 4% of the pixel size

No significant σ_x difference between ADC-8 & 10 bit And Due to the low power consumption and small size, **ADC-8bit is chosen**

Pos Reso $\sigma_{\!x} \, @$ N-bit and different Resister





Sharing determination of AC-LGAD by beta source



Ch.24 -> 19 - Ch.24 -> 18

80

Sharing from Ch.24 to 18, 19

60

40

60

50

40

30

20

10

20



Beam hole for Sr-90 [37MBg]

- The Beta source is placed right above sensor, 5~10 cm away.
- High voltage is -170V

- The whole setup put in black box



- From the beta source measurement. we can get \sim 30% of sharing - The discrepancy in inject charge and beta source

2

6

24 share to 18 and 19

NC

21

measurements comes from the TDC distortion

100 Sharing [%]

Summary

- The radiation tests of 10 crystals proved their good radiation hardness
- The light yield of the 10 crystals measured are consistent and fulfill the criteria of the experiment
- The basic simulation construction of EEMC is completed and the performance is consistent with the requirements.
- The ADC-8bit will be adapted based on the chip position resolution study
- The sharing of AC-LGAD is determined by both charge injection(~15%) and beta source(~30%).

Outlook:

- More advanced simulations of the EEMC: mechanical structure, improved clustering, etc.
- Laser tests of the AC-LGAD sensors. Laser can offer desired charge injection and position

BACKUP

Backup Calorimeter - crystal radiation hardness



Backup Calorimeter pion rejection

- EMCalorimeter can also be used for particle identification
- To separate e- and pi-, one can use the ratio of energy deposition (calorimeter) and momentum (tracker)



Pion rejection factor inner[crystal] and outer[sci-glass]



Pion rejection factor v.s. energy

Backup **Calorimeter Pi0 reconstruction**

- DIS process -> pi⁰ and photon in electron-going direction
- pi^o -> 2g , br(0.988), pi^o life time: 8.5x10-17s •
- Calorimeter needs to separate two nearby photon ٠
- The pi0 efficiency can be improved by the clustering algorithm

(work in progress)



 π^0 from simulator reconstruct efficiency





Two closed photon



Simulation of signal sharing among neighboring pixels

- The purpose is to know the difference in position resolution for ADC 8 or 10 bit
- The position of the injected charge can be calculated by: $\Sigma(Pos_i * V_i) / \Sigma V_i$
- The position resolution is the RMS of $\Delta D = (\text{Reco Pos} \text{Inject Pos})$

